

**OLIFF & BERRIDGE, PLC**  
ATTORNEYS AT LAW

**Application Data Sheet**

**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Marc
Family Name::	RABAROT
City of Residence::	Saint-Egrêve
Country of Residence::	France

Applicant Authority Type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Jacqueline
Family Name::	BABLET
City of Residence::	Le Gua
Country of Residence::	France

**Correspondence Information**

Correspondence Customer Number:: 25944

**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	MICROSTRUCTURE COMPRISING AN ADHESIVE LAYER AND METHOD OF FABRICATION OF SAID MICROSTRUCTURE
Attorney Docket Number::	124253
Suggested Drawing Figure::	5
Total Drawing Sheets::	4
Small Entity::	No

**Representative Information**

Attorneys associated with Customer No. 25944.

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/FR03/03788	12/18/03
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
France	02 16272	12/20/02	Yes
<b>Assignee Information</b>			
Assignee Name::	Commissariat à l'Energie Atomique		
Street of mailing address::	31-33 Rue de la Fédération		
City of mailing address::	Paris		
Country of mailing address::	France		
Postal or Zip Code of mailing address::	F-75752		